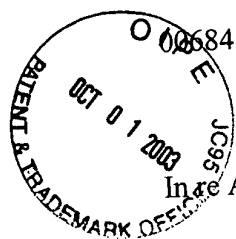


PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Application of:

Yuichi YAMADA et al.

Application No.: 10/024,139

Filed: December 21, 2001

For: SCANNING EXPOSURE APPARATUS AND)
DEVICE MANUFACTURING METHOD : October 1, 2003
(As Amended))

)
: Examiner: Que Tan Le
)
: Group Art Unit: 2878
)
: Confirmation No.: 4039
)
:

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL PRELIMINARY AMENDMENT

Sir:

Further to the Preliminary Amendment filed on August 20, 2003, and prior to further examination on the merits, please amend the above-identified application as follows: